

CYNETICS OF MOLECULAR NITROGEN IONIZATION IN
PLASMA OF GAS DISCHARGE ION SOURCE

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A model is suggested which describes the destruction of N_2 molecules in the gas discharge medium with the pressure of 1-10 Pa. The self-consistent problem is solved using basic different equations system of chemical cynetics. The optimal parameters of discharge are presented which ensure the maximal yield of the N_1^+ component for given energy contribution. The conclusions on mechanism and optimal parameters of gas discharge regime are derived on the basis of comparison of calculated and experimental data achieved on duoplasmatron type injector of RP linear accelerator. The possibilities are discussed of the use of this calculation model for an analysis of physical effects in the region of formation of plasma-type emitter.

1. INTRODUCTION

Nitrogen ion implantation is used widely to increase the surface hardness of metals which results in the large increase in the lifetime of mashines [1]. Deep implanted layers are preferred which make wanted the implantation of N^+ rather than that of N_2^+ ions. Early experimental results show that better wear and corrosion resistances are achieved when implantation is done with only N^+ ions rather than with the mixed N^+ , N_2^+ ion beam [2]. A pure beam of N^+ ions is desirable since the mass separation entails the use of a large magnet. Elimination of the mass separation procedure allows a simpler, more efficient and compact ion accelerator as a whole. Application of pure nitrogen beam in technology defines the interest for plasma cynecic parameters of this gas [3,4]. In this paper non-stationary nitrogen plasma is explored. An attempt is made to develop the calculation model of nitrogen plasma in the range of small value of discharge current density. The important purposes of the numerical simulation are the definition of internal plasma parameters (charged particles concentration, exited particles, radicals) when external parameters are given (gas pressure, discharge current and voltage, geometrical factor, sort of the working gas), the calculation of the chemical reactions cynecics in plasma volume and on the electrode surfaces, the search of the discharge parameter (electron temperature, specific energy contribution and ionization efficiency) leading to the minimal power consumption.

2. EXPERIMENTAL SETUP

The source geometry has been already

described [5]. The source consists of the air cooled electrodes with the duoplasmatron-type configuration. A hollow cathode (2,5 cm diam, 10 cm depth) made of aluminium is positioned on the source axis. A magnetic field is produced by permanent magnets, which provide a longitudinal magnetic field in the anode region with the magnitude of about 0,2 T at the axis. The open end of the source is enclosed by the two-electrode acceleration system and an einzel lens focusing system. Nitrogen ions are extracted from the source through the 0,5 mm diam aperture. Located downstream from the einzel lens is the magnetic deflection spectrometer to define the ion species in the extracted beam. The Faraday cup is located further downstream. All the measurements are performed with the source and extraction operated in dc and pulse mode. The ion energy is estimated near 30 keV.

3. SOLUTION OF NITROGEN PLASMA CYNETICS. THEORETICAL MODEL.

Complicated chemical reaction may be described by the system of stehiometric equations:

$$\sum_{i=1}^N \nu'_{ij} M_i \rightarrow \sum_{i=1}^N \nu''_{ij} M_i, \quad j=1,2,\dots,L, \quad (1)$$

where L - the number of elementary stages; ν'_{ij}, ν''_{ij} - stehiometric coefficients of the i -substance participating in the j -reaction as a initiating reagent and resulting product correspondingly; M_i - the amount of i -substance in the system.

The rate of the process is given by [6]:

$$\frac{dn_i}{dt} = \sum_{j=1}^M (\nu''_{ij} - \nu'_{ij}) (K_{fj} \prod_{i=1}^N n_i^{\nu'_{ij}} - K_{bj} \prod_{i=1}^N n_i^{\nu''_{ij}}), \quad (2)$$

where n_i - the density of i -substance; K_{fj} and K_{bj} - constants of the direct and inverse reactions correspondingly.

Equation (2) includes value n_i for $[N^+]$ ions, where $[N^+]$ - the density of nitrogen atomic ions, obtained in appropriate processes (1,2) so it is necessary to solve the hard basic different equations system (BDE) of chemical cynetics.

The following typical process have been analysed:

1. Settling and desactivation of levels $N_2(C^3\Pi_u)$ with constants $k1.1 - k1.10$;
2. Settling of levels $B^3\Pi_g$ with the constants $k2.1 - k2.13$;
3. Destruction of levels $B^3\Pi_g$ with the constants $k3.1 - k3.6$,

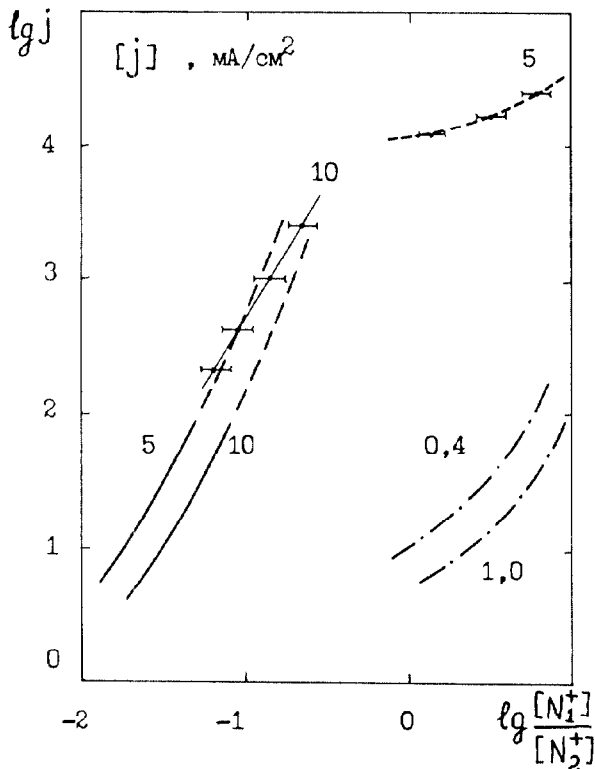


Figure 2 Calculated and experimental value of $\log[N_1^+]/[N_2^+]$ in dependence on discharge current density $\log j$: ———— - theoretical results (small currents); ———— - experiment (dc mode of operation); - - - - - experiment (pulse mode of operation); - - - - - experimental data [10]; - - - - - extrapolation of theoretical data (high discharge currents); parameter of curves - the gas pressure in discharge chamber, Pa.

4. THEORETICAL AND EXPERIMENTAL RESULTS.

We present some mechanism of nitrogen ions generation which may be used for description of $[N_1^+]/[N_2^+]$ experimental dependences on initial neutrals density and discharge current density. Errors are stipulated by mistakes in particle density as well as coefficients of processes rate. Theoretical and experimental data for small discharge currents are shown on fig. 2. Theoretical investigation of feasible mechanisms of nitrogen destruction has shown that high efficiency is reached in non-equilibrium conditions ($T_e \gg T_0$), where T_0 - neutral gas temperature), when dissociation is stimulated by oscillation excitation of N_2 electron levels. Furthermore, the creation of N_1^+ ions by electron impact, their recharging and destruction by diffusion or diffusion with the three-particle conversion may not explain the experimental data. It is necessary to take into account the ambipolar diffusion across magnetic field.

Experimental dependences of $\log[N_1^+]/[N_2^+]$ for high discharge currents in the range of working gas pressure 5-10 Pa are shown on the

same fig.2. Experimental data inside considered error range for investigated space of parameters accounting extrapolation procedure are in good agreement with the theoretical results. It seems that significant distinction of theoretical and experimental data [10] (see fig.1.), may be explained by the specific discharge conditions of multicusp anode system possessing of high efficiency of electron energy transfer into plasma by means repeated oscillations. Oscillation of plasma electrons leads to high non-equilibrium state of discharge conditions ($T_e \gg T_0$).

Theoretical analysis of plasma kinetics in the range of high discharge currents shows that additional efforts should be taken to get more correct kinetics coefficients of considerable reactions.

5. CONCLUSION.

Theoretical model and experimental data obtained on duoplasmatron ion source for small discharge current are discussed. Considered calculation algorithm may be successfully applied to an analysis of physical effects in the region of formation of plasma-type emitter. In addition this calculation model might be useful for considering more complicated plasma-creating media, for example, halogens.

6. REFERENCES

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